



Sheet 1 of 1

U.S. Department of Commerce, Patent and Trademark Office	Serial No.: 10/010,786
	Filing Date: 11/09/2001
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Inventors: Novotny, et al.
"MICRO-ELECTRO-MECHANICAL VARIABLE OPTICAL ATTENUATOR"	Group Art Unit: 2874
	Examiner Name: Valencia, Daniel E.
	Attorney Docket No.: 13441-002001 (AO-777)

U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date, If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						

Foreign Patent Documents

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AF							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>JD</i>	AG	US 2002/0005976 A1, Publication date: January 17, 2002. "Multi-Layer, Self-Aligned Vertical Combedrive Electrostatic Actuators and Fabrication Methods." Inventors: Behrang Behin and Satinderpall Pannu. Filed March 14, 2001. Application Number: 09/810,333.
<i>JD</i>	AH	US 2002/0172452 A1, Publication date: November 21, 2002. "Latching Apparatus for a MEMS Optical Switch." Inventors: Nan Zhang, Hong Zhang, and Gary Nault. Filed May 18, 2001. Application Number: 09/860,300.
	AI	
	AJ	

Examiner

John D. Lee

Date Considered

04 March 2004

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.